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G. Meloni



May 4, 2001

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To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

Subject:

Serial No. 09/783,384 02/15/01

Ching-Cheng Huang, Chuen-Jye Lin,
Ming-Ta Lei, Mou-Shiung Lin

RELIABLE METAL BUMPS ON TOP OF I/O
PADS AFTER REMOVAL OF TEST PROBE
MARKS

Grp. Art Unit:

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.

The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56. Copies of each document is included herewith.

U.S. Patent 6,162,652 to Dass et al., "Process for Sort
Testing C4 Bumped Wafers", provides for the testing of an
integrated circuit device including depositing a solder bump on
a surface of a bond pad.

U.S. Patent 5,756,370 to Farnworth et al., "Compliant Contact System with Alignment Structure for Testing Unpackaged Semiconductor Dice", provides a compliant contact system for making temporary connection with a semiconductor die for testing and a method for fabricating the pliable contact system.

U.S. Patent 5,554,940 to Hubacher, "Bumped Semiconductor Device and Method for Probing the Same", addresses the probing of semiconductor devices that have been provided with contact bumps and the formation of peripheral test pads.

Sincerely,

A handwritten signature in black ink, appearing to read 'SBA', is written over the printed name.

Stephen B. Ackerman,
Reg. No. 37761